

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

2003US301/CIP

Application Number

10/658,840

Applicant(s)

Ralph R. DAMMEL et al.

Filing Date

December 17, 2003

Group Art Unit

1756

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JSL		6,048,661	4/11/2000	Nisbi et al.			
JSL		6,548,219	4/15/2003	Ito et al.			

U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

3/2005

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PAGE 4/4 * RCVD AT 11/15/2004 11:44:21 AM [Eastern Standard Time] * SVR:USPTO-EFXXF-1/0 * DNIS:8729306 * CSID:908 429 3650 * DURATION (mm-ss):01:32

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Docket Number (Optional)

2003US301/CIP

Application Number

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Applicant(s)

Ralph R. Dammel et al

Filing Date

September 9, 2003

Group Art Unit

TO BE ASSIGNED

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JH		6,210,859 B1	04/03/2001	Hyun Pyo Jeon et al			
JH		6,274,286 B1	08/14/2001	Jun Hatakeyama et al			

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
JH		WO 95/33753	12/14/1995	Europe				
JH		DE2460537	07/18/1975	Germany (to be sent later)				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
js		2002/0061464 A1	5/23/2002	Aoal et al.			
js		2002/0061466 A1	5/23/2002	Lee et al.			

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
js		DE 2460537						
js		GB 1496757						

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(Including Author, Title, Date, Pertinent Pages, Etc.)

js		PCT Search Report for PCT/EP2004/001194.

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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	5,350,660	09/27/1994	Fumiyoshi Urano et al			
	6,333,436 B1	12/25/2001	Matsu Nakashima et al			
	6,369,276 B1	04/09/2002	Jack S. Warren			
	2002/0061466 A1	05/23/2002	Geun Su Lee et al			
	2002/0081520 A1	06/27/2002	Ratnam Soorlyakumaran et al			
	2002/0090572 A1	06/11/2002	Ratnam Soorlyakumaran et al			

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
js	EP 1 275 666 A1	01/15/2003	Europe				
	WO 00/67072	11/09/2000	WIPO				
	WO 00/17712	03/30/2000	WIPO				
	WO 01/37047 A2	05/25/2001	WIPO				
	WO 02/44811 A2	06/06/2002	WIPO				

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js		Cyclopolymerization and Polymers with Chain Ring Structures, ACS symposium Series 195 Edited by George Butler and Jim E. Kresta, Chapters 2, 3 and 4.
js		Hoang V. Tran et al, "Metal-Catalyzed Vinyl Addition Polymers for 157 nm Resist Applications. 2. Fluorinated Norbornenes: Synthesis, Polymerization and Initial Imaging Results", Macromolecules 2002, 36, 6539-6549

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	FILING September 9, 2003	GROUP 1756

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						YES	NO
JS	JP8176051	07/09/1996	Japan				
	JP8193055	07/03/1996	Japan				
	JP1312065	12/15/1989	Japan				
	JP9211865	08/15/1997	Japan				

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JS			Shun-ichi Kodama et al, "Synthesis of Novel Fluoropolymer for 157 nm Photoresists by Cyclo-polymerization", Advances in Resist Technology and Processing XIX, SPIE, Vol 4690 (2002) pages 76 - 83

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